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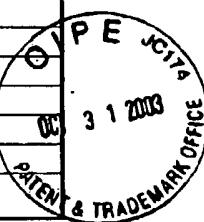
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<p>Substitute for form 1449A/PTO</p> <h2>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</h2> <p><i>(use as many sheets as necessary)</i></p>				<p><i>Complete if Known</i></p>	
				Application Number	10/046,893
				Filing Date	January 17, 2002
				First Named Inventor	Osamu Nakamura et al.
				Group Art Unit	2823
				Examiner Name	H. Lee
Sheet	1 (List 1)	of	1	Attorney Docket Number	0756-2424



U.S. PATENT DOCUMENTS

Examiner Initials	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
<i>Jee</i>		6,204,154		Zhang et al.	03/20/2001	
		6,355,509		Yamazaki	03/12/2002	
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Sheet	1 (List 2)	of	4	Filing Date	January 17, 2002
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				Group Art Unit	2823
				Examiner Name	H. Lee
				Attorney Docket Number	0756-2424



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		Number	Kind Code ³ (if known)			
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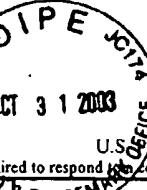
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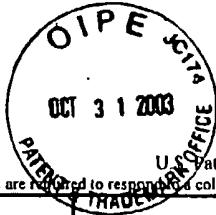
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Signature

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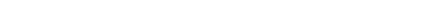
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				Filing Date	January 17, 2002
				First Named Inventor	Osamu NAKAMURA et al.
				Group Art Unit	2823
				Examiner Name	H. Lee
Sheet	3 (List 2)	of	4	Attorney Docket Number	0756-2424

U.S. PATENT DOCUMENTS

Examiner Signature		Date Considered	12/31/63
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Application Number	10/046,893
Sheet	4 (List 2)	of	4	Filing Date	January 17, 2002
				First Named Inventor	Osamu NAKAMURA et al.
				Group Art Unit	2823
				Examiner Name	H. Lee
				Attorney Docket Number	0756-2424

FOREIGN PATENT DOCUMENTS							
Examiner Initials ¹	Cite No. ¹	Foreign Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ²
		Office ³	Number ⁴ (if known)				
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<i>Lee</i>	EP	0 651 431			05/03/1995		ENG

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.				T ²
<i>Lee</i>		Masayasu Miyake et al., <i>Characteristics of Buried-Channel pMOS Devices with Shallow Counter-Doped Layers Fabricated Using Channel Preamorphization</i> , IEEE Transactions on Electron Devices, Vol. 43, No. 3, March 1996, pp. 444-449				
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